

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Lee et al.

Serial No: 10/613,331

Filed: July 3, 2003

) Title: METHOD FOR FORMING
) METAL SILICIDE LAYER IN
) ACTIVE AREA OF
) SEMICONDUCTOR DEVICE
)
) Group Art Unit: 2823
)
) Examiner: Brook Kebede

TRANSMITTAL OF CORRECTED DRAWINGS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Attention: Official Draftsman

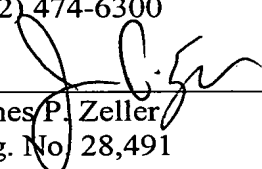
Sir:

Enclosed herewith is a replacement sheet for Fig. 1 for substitution in the above-referenced application.

Respectfully submitted,

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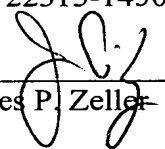
By:


James P. Zeller
Reg. No. 28,491

October 11, 2005

CERTIFICATE OF MAILING (37 CFR 1.8)

I hereby certify that this paper and the documents referred to as enclosed therewith are being deposited with the United States Postal Service as first class mail, postage prepaid, on ~~August~~ ^{October} 11, 2005, in an envelope addressed to the Commissioner for Patents, Attention Official Draftsman, P.O. Box 1450, Alexandria, VA 22313-1450.


James P. Zeller